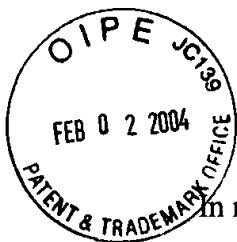


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PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NOBUHIRO ITO

Application No.: 09/505,627

Filed: February 16, 2000

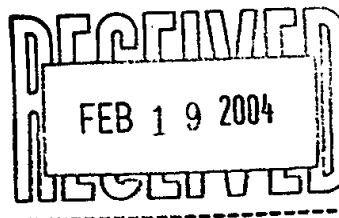
For: MANUFACTURING METHOD OF  
ELECTRON BEAM APPARATUS  
AND SPACER, AND ELECTRON  
BEAM APPARATUS

Examiner: J. Williams

Group Art Unit: 2879

January 30, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

TC 2800 MAIL ROOM

FEB-4 2004

RECEIVED

Sir:

A. Introductory Remarks

In response to the Office Action dated October 31, 2003, please amend the application as follows and consider the following remarks.

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